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Practitioner's Docket No.: NTI-006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of (1st Inventor): Lynn Cai

Assignee: Numerical Technologies Inc.

Serial No.: 09/814,023

Filed: 03/20/2001

For: "System And Method Of Providing Mask Defect Printability Analysis"

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JUN 25 2001  
TECHNOLOGY CENTER R3700

San Jose, California  
May 14, 2001

Assistant Commissioner of Patents and Trademarks  
Washington, D.C. 20231

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JUL 18 2001  
Technology Center 2600

NOTIFICATION OF LOSS OF ENTITLEMENT  
TO SMALL ENTITY STATUS  
(37 CFR 1.28(b))

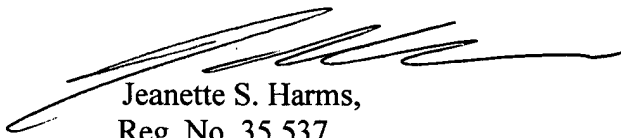
Dear Sir:

Applicant/Assignee hereby notifies the Patent and Trademark Office that it is no longer entitled to status as a small entity, and that the previous claim for small entity status is hereby withdrawn.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as FIRST CLASS MAIL in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C., 20231-0001, on May 14, 2001.

Date: 5/14/01

Signature: Carrie Reddick